

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Yi-Hsun Wu, et al. Applicant:

888888

Not Yet Assigned

Serial No.: 10/687,314

Art Unit:

Examiner:

Filing Date: October 16, 2003 2836

Conf. No.: 7810

Electrostatic Discharge Entitled:

Protection Structure for

Deep Sub-Micron Gate Oxide§

INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

The above-identified application was filed after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of only the foreign patent documents and non-patent literature listed on the enclosed modified Form PTO-1449 are attached.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

Applicants believe no fee is due; However, the Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

David M. O'Dell

Registration No. 42,044

Date: 1-29-04

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Alexandria, VA 22313-1450 on 1-29-04

Bonnie Boyle

Printed Name

Signature

In place of PTO-1449 Form

U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

OF

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NFORMATION DISCLOSURE ATTEMENT BY APPLICANT

(use as many sheets as necessary)

	Complete if Known	
Application Number	10/687,314	
Filing Date	October 16, 2003	
Applicant(s)	Yi-Hsun Wu, et al.	
Art Unit	Not Yet Assigned	
Examiner Name	Not Yet Assigned	
Attorney Docket Number	24061.27 (TSMC2002	

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U. S. PATENT DOCUMENTS				
Examiner's Initials	Cite No.	Document Number *	Publication Date	Name of Patentee or Applicant of Cited Document
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FOREIGN PATENT DOCUMENTS				
Cite No.	Foreign Patent Document (County Code - Number - Kird)	MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation
2697	(Soundy Code - Number - Nino)	2 - Marie Co. S. Same Marie Constitution No.		
	*·· *···········			
	Cite No.	Cite Foreign Patent	Cite: Foreign Patent Publication Date	Cite: Patentee or Applicant of Cited

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
	AA	URL: http://www.eedesign.com/article/showArticle.jhtml?articleld=16503875; VERHAEGE, KOEN G., ESD Process Shrinks I/Os Along Core Path, November 6, 2001, 4 pages, CMP Media LLC., 11/1/01, Issue #13149, page 22.

			
Examiner		Date	
Signature		Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

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